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Applicant(s)/Patent under Reexamination

09/593,891

NAKAYAMA, SADAO

Art Unit

Chris C. Chu

Examiner

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SEARCHED				
Class	Subclass	Date	Examiner	
257	777 and 692	3/16/2005	C.C.	

INTERFERENCE SEARCHED					
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Searched in USPAT; US-PGPUB; USOCR; EPO; JPO; DERWENT; and IBM_TDB;	3/16/2005	C.C.
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